

Group Art Unit: 2886  
Confirmation No.: 3799  
Examiner: Nur, A.

Atty. Ref.: F04-018US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Tohru Koike et al.  
Appl. No. : 10/575,714  
Filed : May 8, 2006  
For : METHOD FOR MEASURING A SURFACE PLASMON RESONANCE AND NOBLE METAL COMPOUND USED FOR THE SAME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**THIRD INFORMATION DISCLOSURE STATEMENT**

Sir:

The above-identified U.S. patent application corresponds to Japanese Patent Appl. No. JP2006-058217. An Office Action was issued in connection with the Japanese application and a copy of that Office Action is attached. The Japanese Examiner cited WO2005/38442 and JP2006-53036 as being relevant. These two references have been listed on the attached copy of Form PTO/SB/08A. WO2005/38442 was published in the Japanese language. However, that reference corresponds to EP1674857. The European equivalent of the WIPO publication also has been listed on the attached copy of the Form PTO/SB/08A and copies of both of these references are attached. The JP2006-53036 reference does not appear to have an English language equivalent. However, that reference is attached along with an English language abstract obtained from the database of the Japanese Patent Office.

The Examiner is requested to consider these references during the examination and to make the references of record.

Respectfully submitted,



Gerald E. Hespos, Esq.

Atty. Reg. No. 30,066

Customer No. 01218

CASELLA & HESPOS LLP

274 Madison Avenue - Suite 1703

New York, NY 10016

Tel. (212) 725-2450

Fax (212) 725-2452

Date: January 11, 2010